

IN THE UNITED STATES
PATENT AND TRADEMARK OFFICE

Declaration and Power of Attorney

As a below named inventor, I hereby declare that:

My residence, post office address and citizenship are as stated below next to my name.

I believe I am an original, first and joint inventor of the subject matter which is claimed and for which a patent is sought on the invention entitled **Process For Fabricating Optical Fiber** the specification of which is attached hereto.

I hereby state that I have reviewed and understand the contents of the above identified specification, including the claims, as amended by an amendment, if any, specifically referred to in this oath or declaration.

I acknowledge the duty to disclose all information known to me which is material to patentability as defined in Title 37, Code of Federal Regulations, 1.56.

I hereby claim foreign priority benefits under Title 35, United States Code, 119 of any foreign application(s) for patent or inventor's certificate listed below and have also identified below any foreign application for patent or inventor's certificate having a filing date before that of the application on which priority is claimed:

None

I hereby claim the benefit under Title 35, United States Code, 120 of any United States application(s) listed below and, insofar as the subject matter of each of the claims of this application is not disclosed in the prior United States application in the manner provided by the first paragraph of Title 35, United States Code, 112, I acknowledge the duty to disclose all information known to me to be material to patentability as defined in Title 37, Code of Federal Regulations, 1.56 which became available between the filing date of the prior application and the national or PCT international filing date of this application:

None

I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code and that such willful false statements may jeopardize the validity of the application or any patent issued thereon.

I hereby appoint the following attorney(s) with full power of substitution and revocation, to prosecute said application, to make alterations and amendments therein, to receive the patent, and to transact all business in the Patent and Trademark Office connected therewith:

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Full name of 1st joint inventor: **Mary Louise Mandich**

Inventor's signature Mary Louise Mardach Date 7/1/98

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Full name of 2nd joint inventor: William David Reents Jr.

Inventor's signature William David Kents Date 7-1-98

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IN THE UNITED STATES
PATENT AND TRADEMARK OFFICE

Patent Application

Inventor: Mary Louise Mandich
William David Reents Jr.

Case: Mandich 6-7

Serial No.: 09/109,827

Group Art Unit: 1731

Filed: July 2, 1998

Examiner: J. Hoffman

Title: Process For Fabricating Optical Fiber

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

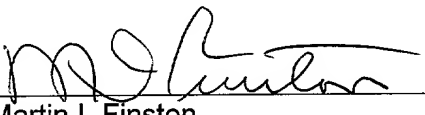
Associate Power Of Attorney

Please recognize John F. McCabe, Reg. No. 42,854 of Lucent Technologies, Inc., 600 Mountain Avenue, Murray Hill, NJ 07974-0636, as an Associate Attorney in the above-mentioned application, with full power to prosecute said application, to make alterations and amendments therein, and to transact all business in the Patent and Trademark Office connected therewith.

Telephone calls should be made to the said Associate Attorney by dialing (908) 582-6866.

All written communications, however, are to be addressed to **Docket Administrator (Room 3J-219), Lucent Technologies Inc., 101 Crawfords Corner Road, Holmdel, NJ 07733-3030.**

Respectfully,

By 
Martin I. Finston
Attorney for Applicant(s)
Reg. No. 31,613

Date: July 24, 2001
Docket Administrator (Room 3J-219)
Lucent Technologies Inc.
101 Crawfords Corner Road
Holmdel, NJ 07733-3030

**IN THE UNITED STATES
PATENT AND TRADEMARK OFFICE**

PATENT APPLICATION

Inventors: Mary Louise Mandich
William David Reents

Case No. 6-7

Title Process For Fabricating Optical Fiber

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D. C. 20231

SIR:

DECLARATION UNDER 37 C.F.R. § 1.132

1. I, Mary L. Mandich, received a Ph.D. in Chemistry from Columbia University. I have been employed at Bell Laboratories since 1983, and have at least 5 years of experience in technologies relating to optical fiber fabrication, including sol-gel technology and preform manufacture. I am a coinventor of the above-captioned patent application.

2. I, William D. Reents, Jr., received a Ph.D. in Chemistry from Purdue University. I have been employed at Bell Laboratories since 1980, and have at least 8 years of experience in technologies relating to optical fiber fabrication, including sol-gel technology and preform manufacture. I am also a coinventor of the above-captioned patent application.

3. I am familiar with the references cited in what I understand to be the final Office Action in my parent application, specifically U.S. Patent No. 4,969,941 to Kyoto et al. ("Kyoto"), U.S. Patent No. 5,356,447 to Bhandarkar ("Bhandarkar"), and U.S. Patent No. 4,264,347 to Shintani et al. ("Shintani").

4. I have considered the Kyoto reference. It is clear to me that Kyoto discusses only soot bodies formed by VAD (vapor axial deposition) or

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OVD (outside vapor deposition) processes. For example, I note the discussion at Col. 1, lines 18 to 56, which relates solely to VAD. I also note the discussion at Col. 7, lines 18 to 32, which would indicate to someone skilled in the art of fiber preforms that Kyoto is referring to VAD or OVD bodies. I further note the discussion at Col. 16, lines 16 to 37, which also would indicate a VAD or OVD body.

5. These VAD or OVD soot bodies of Kyoto are not sol-gel bodies, e.g., bodies made according to a process such as disclosed in U.S. Patent No. 5,240,488, which I note is discussed in the Background section of my patent application. No one skilled in the art of fiber preform manufacture would consider these soot bodies to be sol-gel bodies.

6. One skilled in the art of fiber preform manufacture is aware that VAD and OVD bodies, such as discussed in Kyoto, typically do not contain a measurable amount of refractory metal oxide particles, unlike sol-gel bodies. Specifically, the gases used in VAD and OVD processes to form a glass body (e.g., SiCl_4) are of such high purity that substantially no refractory metal oxide particles exist in the formed body.

7. By contrast, sol-gel bodies typically start with a silica particle dispersion. Due to contamination present in the initial silica dispersion and introduced by both mixing and molding equipment, the presence of refractory metal oxide particles in the formed sol-gel body is typically unavoidable. This contamination is discussed in the Background section of the patent application at page 3, lines 13 to 15.

8. I note that Shintani discloses a step of exposing the sintered silica body to hydrofluoric acid prior to gas treatment, in order to clean the surface of the sintered body, e.g., at Col. 4, lines 13-15. This HF cleaning step could not be performed on a porous glass body, e.g., a pre-sintered sol-gel body of the type discussed in Bhandarkar, without substantially destroying the porous glass body.

9. It was discovered subsequent to filing my parent application that the effectiveness of thionyl chloride (SOCl_2) is highly dependent on the furnace configuration, the type of gas flow over the body in the furnace, the loading of the furnace, etc. Some of the data presented in the application regarding the effectiveness of thionyl chloride in etching refractory metal oxide particles was obtained from different furnaces, and the results therefore are not necessarily illustrative of the advantages of the invention. Specifically, the experiments reported in Tables 1 through 4 for 17% thionyl chloride were performed in a different furnace than the 18% thionyl chloride runs reported in Tables 2 and 4, which explains the differing results.

10. The reasons for thionyl chloride's high sensitivity appears to be related to its slow decomposition. As reflected in the table below, small changes in residence time of thionyl chloride within a furnace can have significant effects on the concentration, due to this slow decomposition. (See, e.g., the significant difference between 4 minutes and 5 minutes.) Thus, the particular furnace configuration, gas flow, furnace loading, etc. will affect the concentration of thionyl chloride that reaches a particular body, and will thereby effect the extent of particle etching performed.

Volume percent of thionyl chloride delivered as measured by mass spectrometry, versus residence time of the thionyl chloride in the same furnace

Measured Vol.% Thionyl Chloride	Residence time (minutes)
20	4
10	5
9.2	40
7.8	160

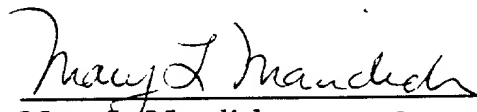
My experience with thionyl chloride, consistent with the above discussion, has clearly indicated that the compound is highly sensitive to a variety of treatment conditions, this sensitivity creating the potential for interference with the desired etching of refractory metal oxide particles. By contrast, I

have neither observed nor am aware of any such sensitivity in sulfur chloride treatments of sol-gel bodies.

11. Because of this sensitivity of thionyl chloride, a meaningful comparison of thionyl chloride etching rates to sulfur chloride etching rates can only be made where the experiments were performed under the same furnace conditions. In the application, such a meaningful comparison is found in Tables 2 and 4, e.g., for the 6.4% sulfur monochloride vs. the 18% thionyl chloride, which were tested under the same furnace conditions. (The data of Tables 1 and 3 does not include thionyl chloride runs performed in the same furnace as sulfur chloride runs.) The Tables clearly show that the sulfur monochloride is equally effective as thionyl chloride, but at nearly 1/3 the concentration, which is a major advantage in a commercial process. In addition, sulfur dichloride tested at a concentration of 3.2% and a temperature of 650°C, in the same furnace and according with the same techniques described in the application, exhibited a volume normalized etch rate for zirconia (see Table 4) of about 60 moles/hour. Thus, the sulfur dichloride is even more efficient, i.e., able to provide about the same etching rate with half the concentration of sulfur monochloride and nearly 1/6 the concentration of thionyl chloride.

12. All statements made herein based on my own knowledge are true, and statements made on information and belief are believed to be true. I understand that willful false statements and the like are punishable by fine and/or imprisonment (18 U.S.C. § 1001), and may jeopardize the validity of the present application and any patents issuing from the present application.

Date: 12-29-99


Mary L. Mandich

Date: 12-9-99


William D. Reents, Jr.